



35.C13974

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAHIRO OHMI, ET AL.

Application No.: 09/425,015

Filed: October 25, 1999

For: GAS SUPPLY PATH
STRUCTURE, GAS SUPPLY
METHOD, LASER OSCILLATING
APPARATUS, EXPOSURE
APPARATUS, AND DEVICE
PRODUCTION METHOD

Examiner: D. Monbleau

Group Art Unit: 2881

October 31, 2001

Commissioner for Patents
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

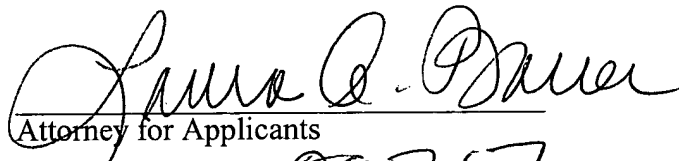
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 7, 2001 for one month from October 7, 2001 to November 7, 2001.

Submitted herewith is a check for \$110.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

Registration No. 091767

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